NOTES:

SHAPE

BEVEL

CLEAR APERTURE

SURFACE QUALITY

SURFACE FLATNESS

1. SUBSTRATE: Silicon (Si)

2. SURFACE S2 TO BE PARALLEL WITH S1 TO <3 ARCMIN

3. COATING (APPLY ACROSS CLEAR APERTURE) S1 & S2:

R(AVG) <1% @ 1650 - 3000nm R(ABS) <2% @ 1650 - 3000nm

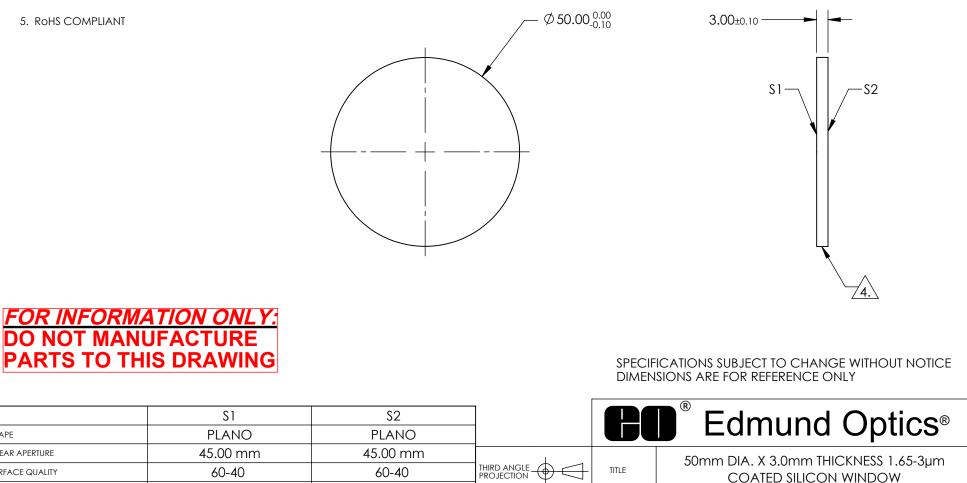
1λ

PROTECTIVE AS NEEDED

1λ

PROTECTIVE AS NEEDED

FINE GRIND SURFACE 4.

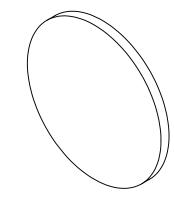


ALL DIMS IN

mm

DWG NO

17203



SHEET

1 OF 1